

Arrival Time and Energy Jitter Effects on the Performance of X-ray Free Electron Laser Oscillator



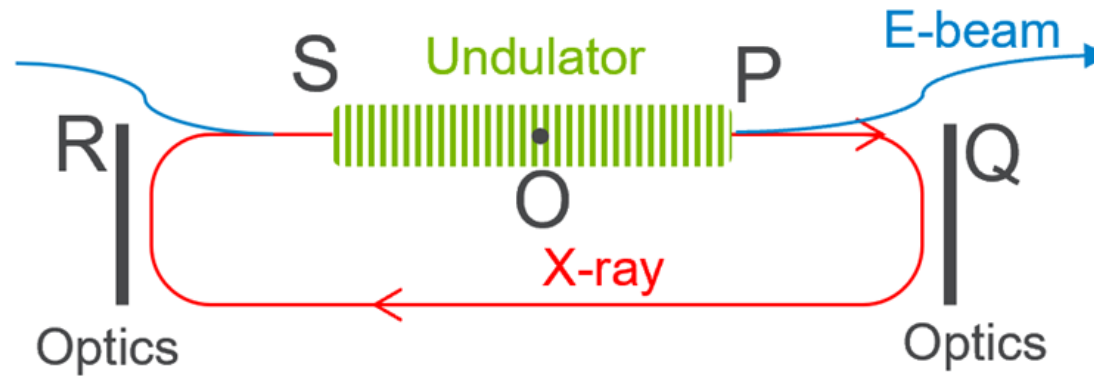
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Concept of X-ray laser: The X-ray FEL oscillator (XFELO)



Schematic of cavity-based X-ray FEL. Not drawn to scale.

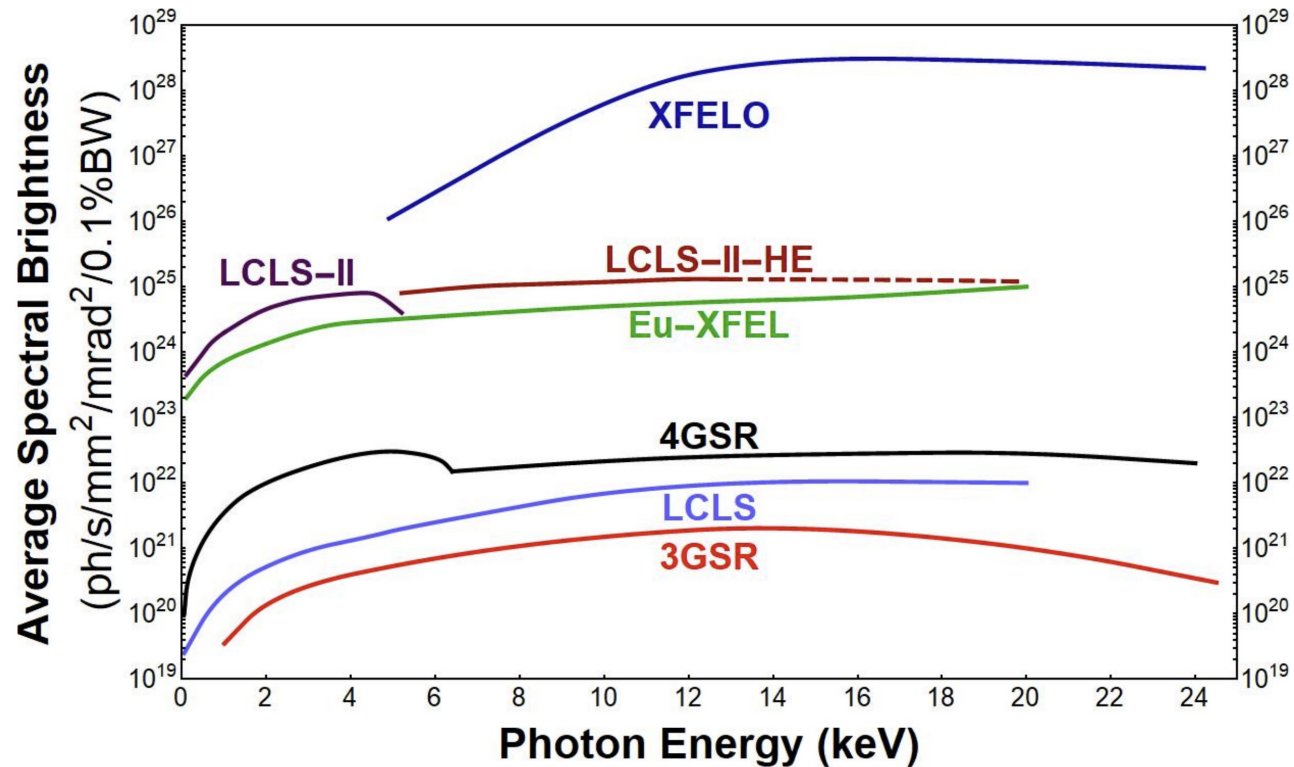
- When the FEL gain and outcoupling are HIGH, the oscillator is referred to as **X-ray regenerative amplifier FEL (XRAFEL)** [1].
- The configuration with low-gain FEL and low outcoupling is called **X-ray FEL oscillator** [2, 3].

[1] Z. Huang and R.D. Ruth, Phys. Rev. Lett. **96**, 144801 (2006).

[2] R. Colella and A. Luccio, Opt. Comm. 50, 41 (1984).

[3] K.-J. Kim, Y. Shvyd'ko, and S. Reiche, Phys. Rev. Lett. 100, 244802 (2008).

Application domains of X-ray FEL oscillator (XFELO)



Photon brightness from XFELO and other light sources [5].

- Science applications and extensions [4]:
 - Inelastic x-ray scattering
 - Nuclear resonant scattering
 - X-ray photoemission spectroscopy
 - Hard x-ray imaging
 - X-ray photon correlation spectroscopy
 - ... and more
- XFELO opens the possibility of adopting advanced optical techniques such as **Q-switching [5]**, **mode-locking [6]**, **parametric amplification [7]** and so on, thereby bringing atomic laser properties to the X-ray regime.

[4] [arXiv:1903.09317v2](https://arxiv.org/abs/1903.09317v2).

[5] J. Krzywinski et al., Proc. of the 39th International Free-Electron Laser Conf. (2019) [TUP033].

[6] B. W. Adams and K.-J. Kim, Phys. Rev. ST Accel. Beams **18**, 030711 (2015).

[7] K.-J. Kim, Z. Huang, and R. Lindberg, Synchrotron Radiation and Free-Electron Lasers: (Cambridge University Press, Cambridge, 2017) and references within.

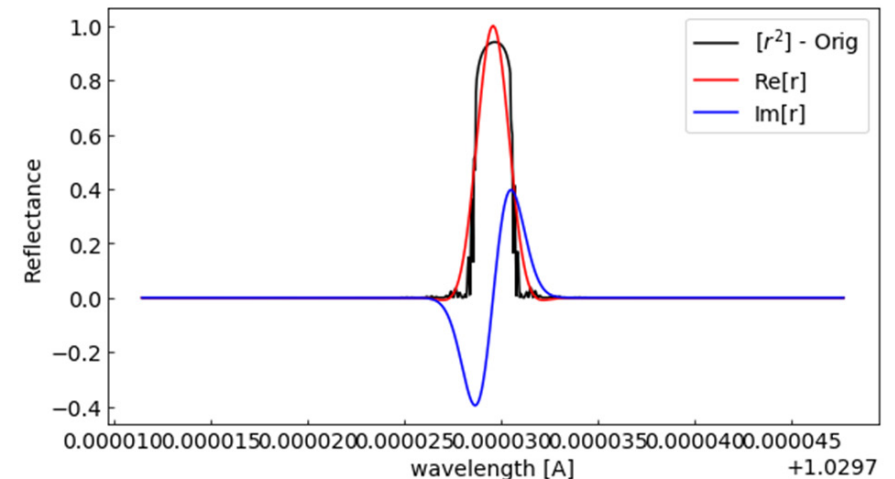
Moving from concept to design tolerances in XFEL

- XFEL's performance depends on the quality and alignment of e-beam and optical cavity.
- Effects of transverse spatial misalignment on XFEL performance is reported elsewhere [8].
- Fluctuations in arrival time and energy of the e-beam can affect XFEL throughput.
- For simplicity, we approximate the reflectivity of the bragg-crystals (or of the optical cavity) by

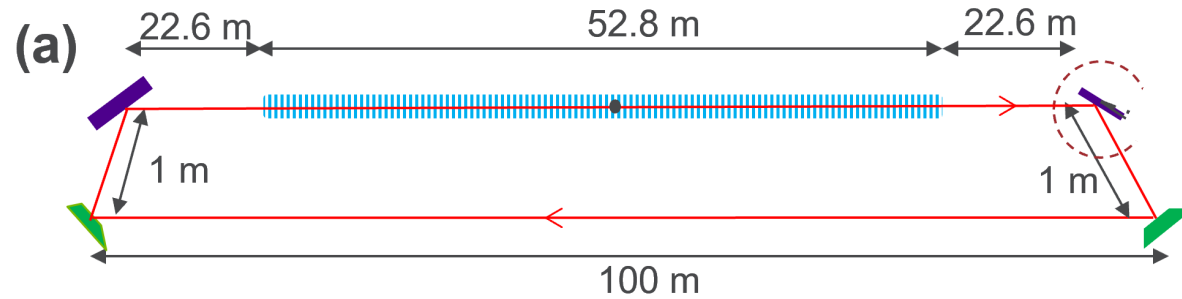
$$\mathcal{R}(\omega) = \sqrt{R} e^{-\frac{(\omega - \omega_c)^2}{4\sigma_{refl}^2}} + i \operatorname{atan}\left(\frac{\omega - \omega_c}{2\sigma_{refl}}\right)$$

where R is the effective power reflectivity of the cavity.

- *A net rms bandwidth of 6.87 meV introduces a delay of ~40 fs per turn, which is compensated by shortening cavity length by the same amount.*



XFELO configuration and parameters for simulations



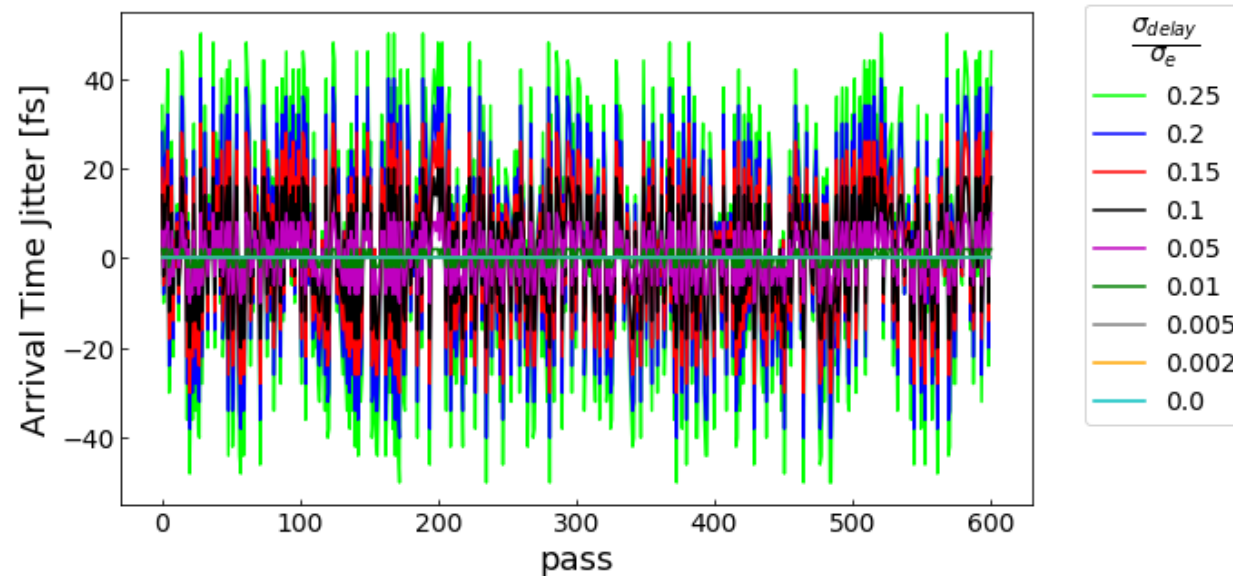
2-crystal cavity configuration with two focusing mirrors for XFEL based on C444 crystal. Not drawn to scale. Geometry is only approximate.

- The generic optical cavity has 15% power loss per turn, defining its **quality factor**, $\hat{q} = \frac{R}{1-R} \cong 5.67$.

Parameter	Symbol (Unit)	A [12 KeV]
Electron beam		
Energy	$\gamma_0 mc^2$ (GeV)	7
Energy spread	σ_γ (MeV)	1.4
Energy shift	δE (MeV)	2.3
Normalized emittance	ε_n (mm. mrad)	0.2
Peak current	I (Amp)	10
Pulse length	σ_t (ps)	0.2
RMS width	σ_x (μm)	12.67
Undulator/Radiation		
Undulator periods	N_u	3000
Undulator length	L_u (m)	52.8
Radiation wavelength	λ_r (\AA)	1.0298
Optical Cavity		
Rayleigh range	Z_R (m)	10
Cavity Length	L_{cav} (m)	200
Stability parameter	$ A + D /2$	0.704
Ideal FEL Gain	G_0	0.44

Jitters in Arrival Time and Energy of Electron Beams

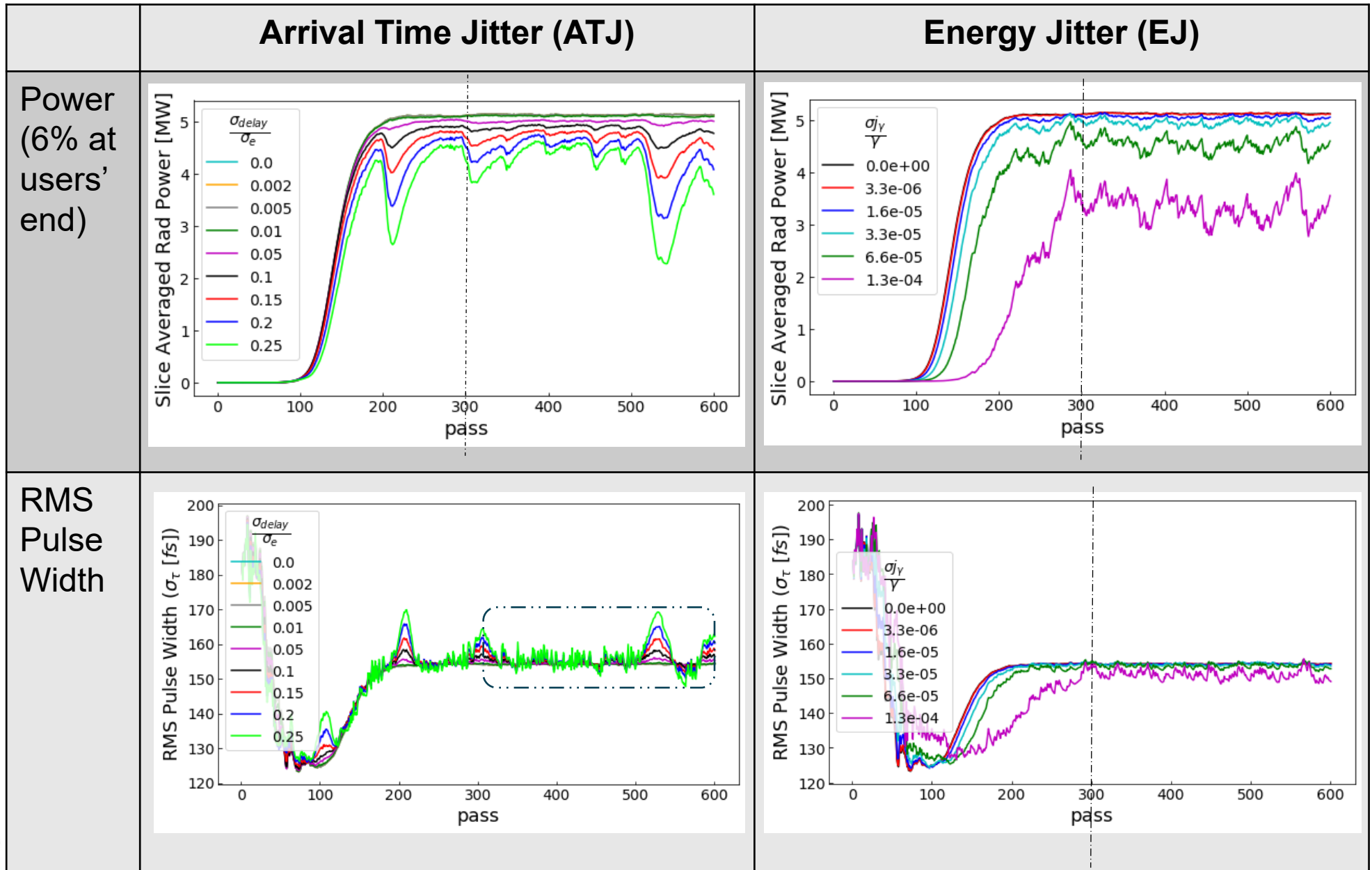
- Turn by turn arrival time jitters (ATJ) and energy jitters (EJ) are artificially generated using random number generation with pre-determined rms values as shown below:



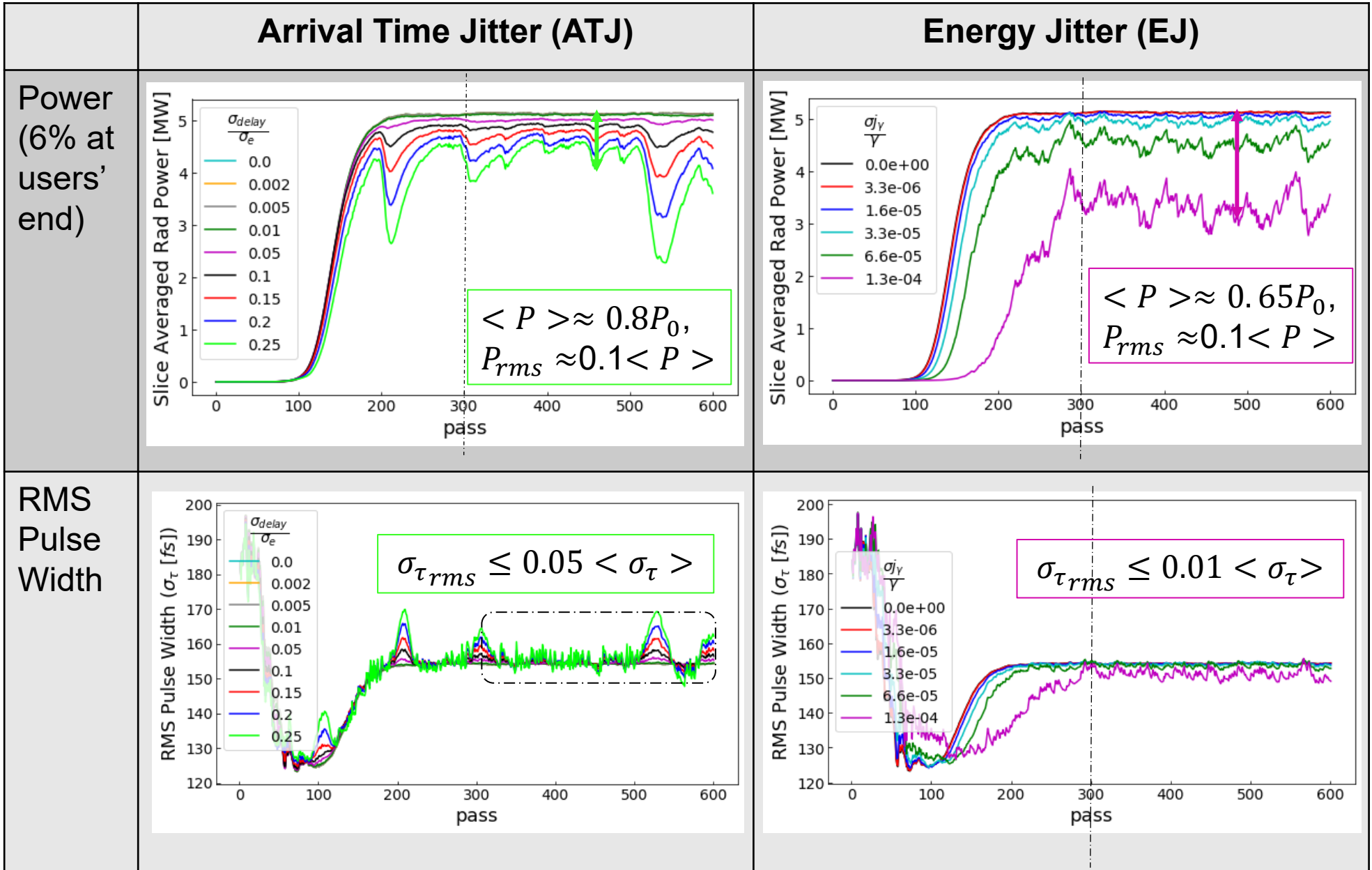
ATJ from 0 to 25% of rms temporal width of e-beam.

- Likewise, rms EJ values ranged from 0 to 0.013% of e-beam energy .
- We observed how jitters affected power output and rms pulse widths after saturation (at steady-state).

Jitter effects in generic cavity ($R=85\%$)



Jitter effects in generic cavity (R=85%)



What can we do about the jitters or their effects?

- Superconducting linacs can (are expected to) achieve [9]
 - energy jitter $\Delta E/E \leq 0.01\%$ and
 - timing jitters of 20 fs (i. e. $\Delta T/T \leq 10\%$ for e-beam with 200 fs rms width).
- However, electron beam jitters become unavoidable for XFEL operation.
- In what ways can we minimize the jitter effects in XFEL performance?
- For an XFEL to sustain lasing, it must satisfy:

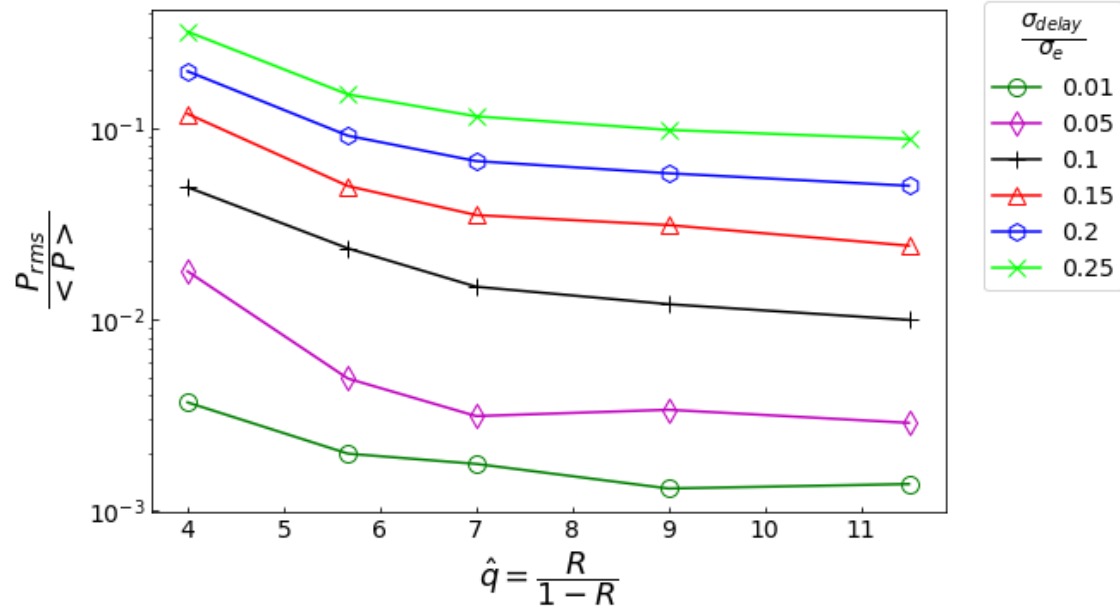
$$R(1 + G) \geq 1$$

where R is net power reflectivity of the cavity and G is FEL gain.

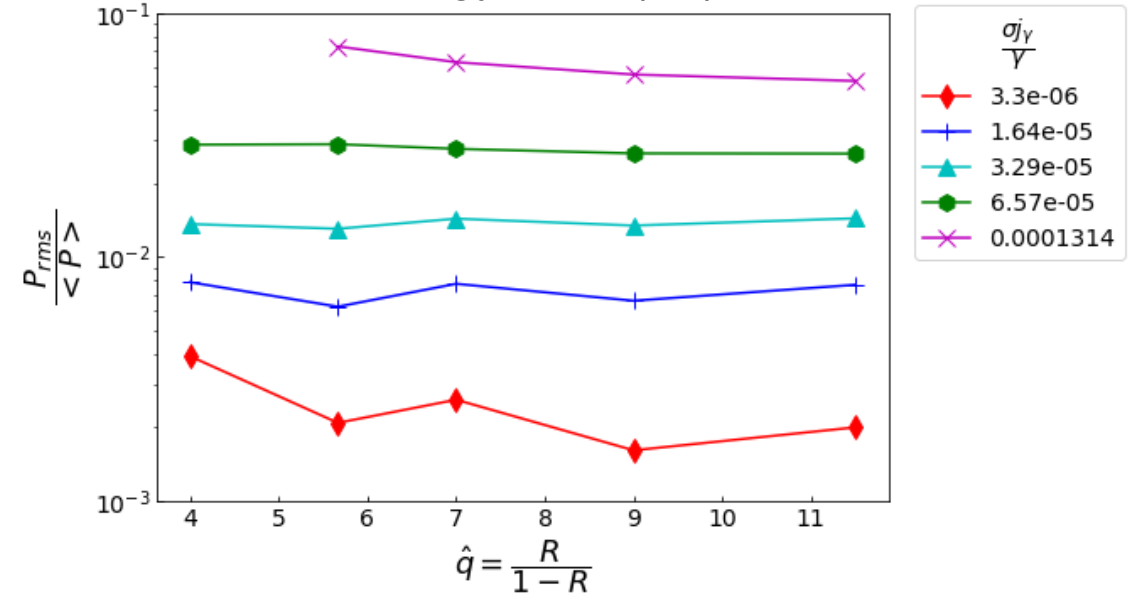
Case I: Jitters and Reflectivity (quality) scan

- We changed the net power reflectivity of the cavity to observe power fluctuations with jitters ON.

Arrival Time Jitter (ATJ)



Energy Jitter (EJ)

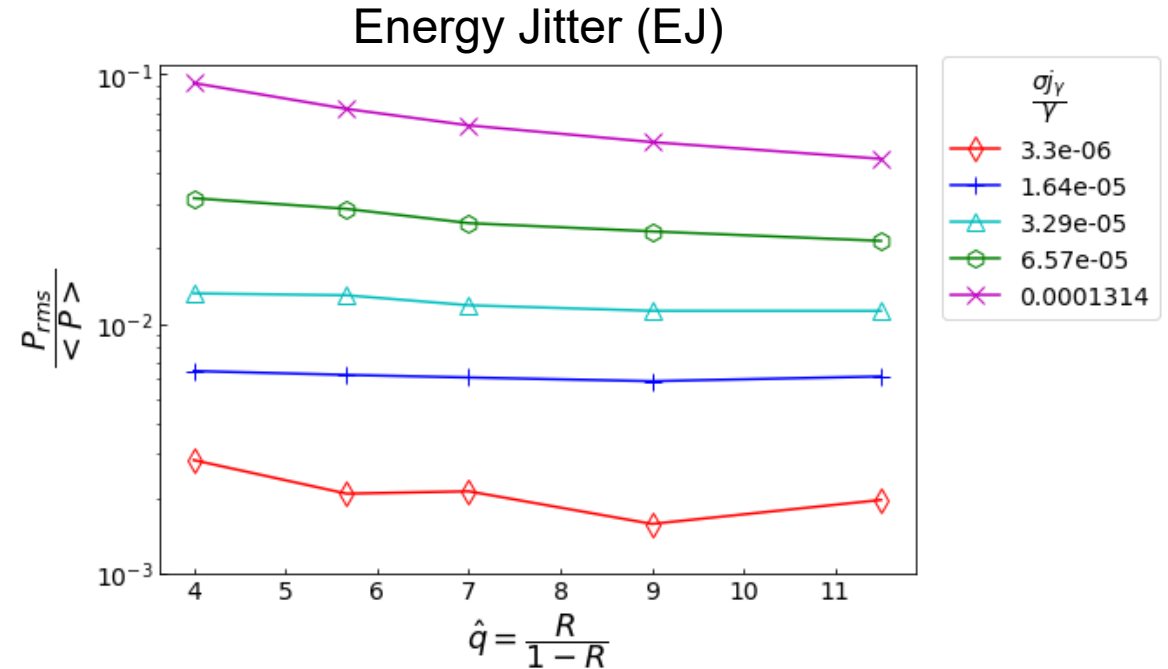
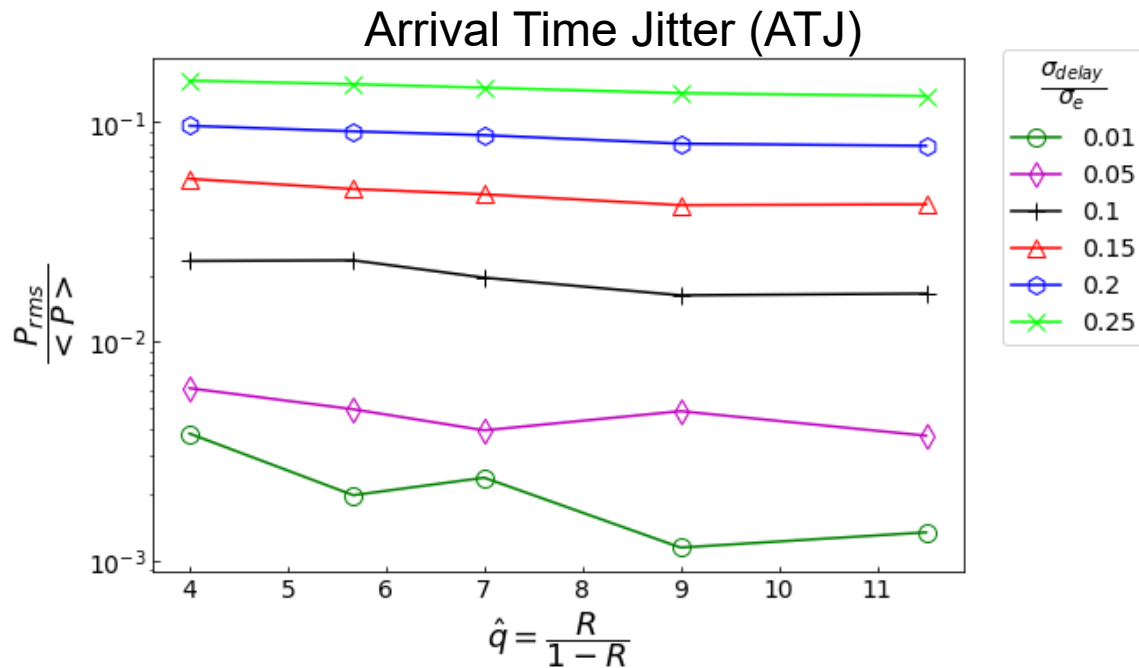


- ATJ within 5% yield fluctuations within 1%.
- ATJ above 15% induce fluctuations >5%.
- Higher reflective (HR) cavities are favorable.

- EJ within 0.005% yield fluctuations within 5%.
- EJ at/above 0.006% generate fluctuations >5%.
- HR cavities favored for mean output, but not fluctuations when EJ is ON.

Case II: Jitters and Reflectivity scan with gain compensation

- Reflectivity scan is now accompanied with a constraint $R(1+G) = \text{constant} = 1.224$.
- Gain is increased (for lossy cavities) or decreased by adjusting beam current.



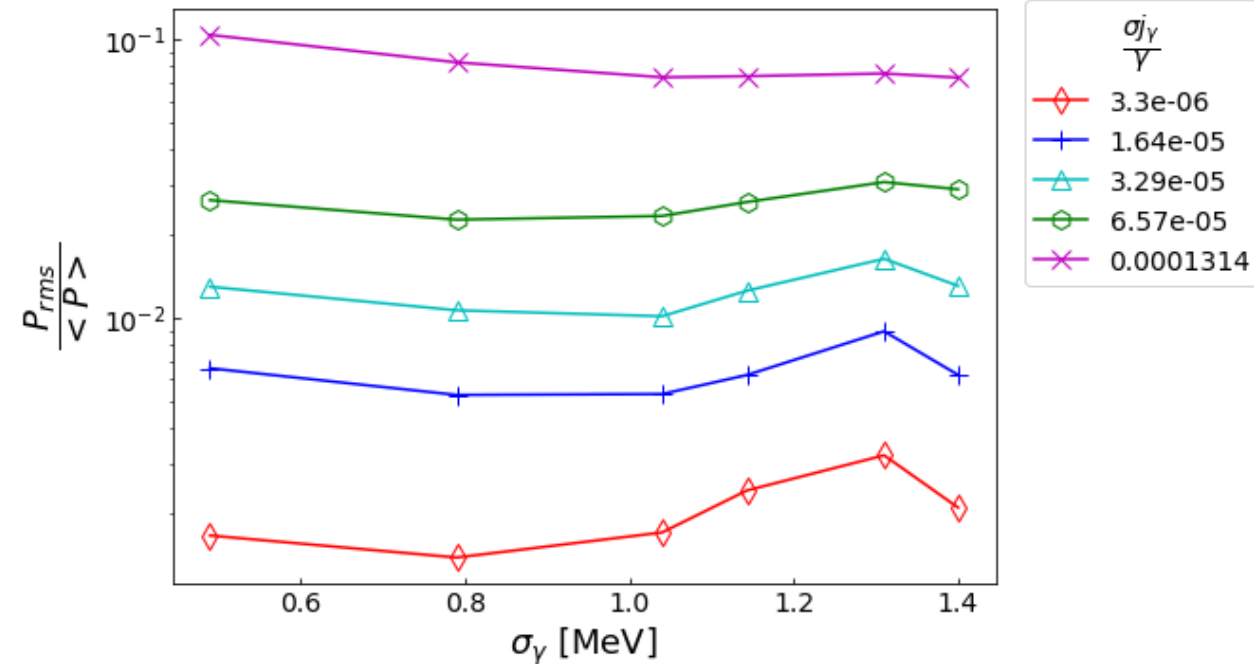
- Gain compensation brings fluctuations to the same level for all cavities with ATJ ON.
- ATJ within 5% yield fluctuations within 1%.
- ATJ above 15% induce fluctuations >5%.

- Gain compensation had minimal effect.
- EJ within 0.005% yield fluctuations within 5%.
- EJ at/above 0.006% generate fluctuations >5%.

Case III: Energy Jitter and FEL efficiency scan

- Finally, both FEL gain and reflectivity are kept constant.
- Energy spread and Number of Undulator Periods are chosen to keep the FEL gain constant.

σ_E (MeV)	N_u
1.4	3000
1.31	2500
1.143	2000
1.04	1800
0.79	1500
0.49	1300



- No significant change in fluctuations is observed for different FELs.
- We plan to investigate this further.

To sum up:

- **Arrival Time Jitter (ATJ):**

- ATJ above 10% is worrisome and is not preferred for XFEL.
- Sensitivity to ATJ effects can be reduced to certain extent by FEL gain compensation.
- RMS pulse width fluctuations due to ATJ is minimal.

- **Energy Jitter (EJ):**

- $EJ < 0.005\%$ of e-beam energy is required to maintain fluctuations within 5%.
- $EJ \geq 0.01\%$ of e-beam energy is troublesome for desired XFEL performance.
- Role of FEL efficiency in mitigating EJ effects require further studies.
- EJ does not induce fluctuations in bandwidth of the radiation pulse.

- We hope to extend this study for an accurate prediction of jitter effects on XFEL performance.

Acknowledgments

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THANK YOU!